PUBLICATIONS

BOOKS


BOOK CHAPTERS


TECHNICAL PAPERS


ENGINEERING EDUCATIONAL RESEARCH PAPERS


PATENTS


F. “Vapor-Phase, Plural-Constituent, Co_Deposition Environment for Production of Thin-Film Device Layer” – R.Wendt, G.M. Hanket, R.W. Birkmire, T.W.F. Russell (filed by Tucson Electric – S.M. 09/613,950; filing date – 7/11/00).